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APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR		ATTORNEY DOCKET NO.	CONFIRMATION NO.
10/791,116	03/02/2004		Ronald S. Cok	87954AJA	2666
7590 11/02/2005				EXAMINER	
Paul A. Leipol	d	BARRECA, NICOLE M			
Patent Legal Sta		ART UNIT	PAPER NUMBER		
Eastman Kodak	Company	AKTONII	PAPER NUMBER		
343 State Street		1756			
Rochester, NY	14650-2201	DATE MAILED: 11/02/2005			

Please find below and/or attached an Office communication concerning this application or proceeding.

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	Application No.	Applicant(s)					
Office A - 4' O	10/791,116	COK, RONALD S.					
Office Action Summary	Examiner	Art Unit					
	Nicole M. Barreca	1756					
The MAILING DATE of this communication appears on the cover sheet with the correspondence address Period for Reply							
A SHORTENED STATUTORY PERIOD FOR REPLY IS SET TO EXPIRE 3 MONTH(S) OR THIRTY (30) DAYS, WHICHEVER IS LONGER, FROM THE MAILING DATE OF THIS COMMUNICATION.  - Extensions of time may be available under the provisions of 37 CFR 1.136(a). In no event, however, may a reply be timely filed after SIX (6) MONTHS from the mailing date of this communication.  - If NO period for reply is specified above, the maximum statutory period will apply and will expire SIX (6) MONTHS from the mailing date of this communication.  - Failure to reply within the set or extended period for reply will, by statute, cause the application to become ABANDONED (35 U.S.C. § 133). Any reply received by the Office later than three months after the mailing date of this communication, even if timely filed, may reduce any earned patent term adjustment. See 37 CFR 1.704(b).							
Status							
<ol> <li>Responsive to communication(s) filed on <u>09 August 2005</u>.</li> <li>This action is <b>FINAL</b>. 2b)∑ This action is non-final.</li> <li>Since this application is in condition for allowance except for formal matters, prosecution as to the merits is closed in accordance with the practice under <i>Ex parte Quayle</i>, 1935 C.D. 11, 453 O.G. 213.</li> </ol>							
Disposition of Claims							
<ul> <li>4)  Claim(s) 1-30 is/are pending in the application.</li> <li>4a) Of the above claim(s) 26-30 is/are withdrawn from consideration.</li> <li>5)  Claim(s) is/are allowed.</li> <li>6)  Claim(s) 1-25 is/are rejected.</li> <li>7)  Claim(s) is/are objected to.</li> <li>8)  Claim(s) are subject to restriction and/or election requirement.</li> </ul>							
Application Papers		•					
<ul> <li>9) The specification is objected to by the Examiner.</li> <li>10) The drawing(s) filed on is/are: a) accepted or b) objected to by the Examiner.  Applicant may not request that any objection to the drawing(s) be held in abeyance. See 37 CFR 1.85(a).  Replacement drawing sheet(s) including the correction is required if the drawing(s) is objected to. See 37 CFR 1.121(d).</li> <li>11) The oath or declaration is objected to by the Examiner. Note the attached Office Action or form PTO-152.</li> </ul>							
Priority under 35 U.S.C. § 119							
<ul> <li>12) Acknowledgment is made of a claim for foreign priority under 35 U.S.C. § 119(a)-(d) or (f).</li> <li>a) All b) Some * c) None of: <ol> <li>Certified copies of the priority documents have been received.</li> <li>Certified copies of the priority documents have been received in Application No</li> <li>Copies of the certified copies of the priority documents have been received in this National Stage application from the International Bureau (PCT Rule 17.2(a)).</li> </ol> </li> <li>* See the attached detailed Office action for a list of the certified copies not received.</li> </ul>							
Attachment(s)    Notice of References Cited (PTO-892)   Notice of Draftsperson's Patent Drawing Review (PTO-948)   Information Disclosure Statement(s) (PTO-1449 or PTO/SB/08)   Paper No(s)/Mail Date	4) Interview Summary Paper No(s)/Mail Da 5) Notice of Informal Pa 6) Other:						

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### **DETAILED ACTION**

1. Applicant's election without traverse of Group I, claims 1-15 in the reply filed on 8/9/05 is acknowledged.

Claims 26-30 are withdrawn from further consideration pursuant to 37 CFR
 1.142(b) as being drawn to a nonelected invention, there being no allowable generic or linking claim. Election was made without traverse in the reply filed on 8/9/05.

## Response to Arguments

3. Applicant's arguments, see the paragraph bridging p.2-3, filed 8/9/05, with respect to Ngyuen have been fully considered and are persuasive. The USC 103 rejections of claims 1-25 have been withdrawn. However, upon further consideration, a new ground(s) of rejection is made in view of French.

# Claim Rejections - 35 USC § 102

4. The following is a quotation of the appropriate paragraphs of 35 U.S.C. 102 that form the basis for the rejections under this section made in this Office action:

A person shall be entitled to a patent unless -

- (e) the invention was described in (1) an application for patent, published under section 122(b), by another filed in the United States before the invention by the applicant for patent or (2) a patent granted on an application for patent by another filed in the United States before the invention by the applicant for patent, except that an international application filed under the treaty defined in section 351(a) shall have the effects for purposes of this subsection of an application filed in the United States only if the international application designated the United States and was published under Article 21(2) of such treaty in the English language.
- 5. Claims 1-25 are rejected under 35 U.S.C. 102(e) as being anticipated by French (US 6,946,410)
- 6. A population of nanostructures are admixed within the dispersant layer and positioned on a substrate. Resist (protective radiation curable layer) is applied and

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exposed to radiation through a mask and developed. A cutting means, such as irradiation with ions, plasma or electrons, is used to form the conductive pattern (col.9. 4-61). Nanostructures may be defined as in col.7, 14-33 and includes tubes, rods and carbon nanotubes. The photoresist is exposed to radiation such as UV light (col.7, 34-67). The nanotubes are aligned or orientated in the dispersant solution (col.8, 59-64). The nanotubes may be continuously cut using a system that will allow for the movement of the solid substrate through baths of various components by attaching the solid substrate to an endless conveyor means such as a belt. The dispersant solution could be dried after coating, in addition to baking (curing) the resist (col.10, 52-67). The dispersion and resist bath dips may be repeated to build up multiple layers. The examples teach exposing the resist through a photomask, or using a stepper rastering back and forth. See specifically Example 4 and 13. The nanotubes may be used in a variety of application including panel displays (col.1, 38-47).

#### Conclusion

7. Any inquiry concerning this communication or earlier communications from the examiner should be directed to Nicole M. Barreca whose telephone number is 571-272-1379. The examiner can normally be reached on Monday-Thursday (9AM-7PM).

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Mark F. Huff can be reached on 571-272-1385. The fax phone number for the organization where this application or proceeding is assigned is 571-273-8300.

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Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

> Nicole M Barreca **Primary Examiner**

Will Ba

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10/30/05